

Notice of References Cited

Application/Control No.

10/659,219

Applicant(s)/Patent Under
Reexamination
JEUTTER ET AL.

Examiner

Edna Wong

Art Unit

1753

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,800,695	09-1998	Kang et al.	205/135
*	B	US-6,335,078	01-2002	Venkataramani et al.	428/139
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 01100302 A	04-1989	Japan	YAMAMOTO et al.	F01D 5/28
*	O	EP 1076107 A1	02-2001	European Patent	BEECK et al.	C23C 4/00
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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